

| INTRODUCTION | | | | | | |
|--|--|---|--|--|--|--|
| With UH4150, a detector can be selected depending on the analysis purpose. When analyzing a solid sample which doesn't contain any diffuse components, by selecting the direct light detector, the measurement of high absorbance can be performed with less noise, compared with the integrating sphere detector. One of the methods to measure high absorbance with a good accuracy is to use an attenuator. The standard installation of UH4150 includes the 1/100 attenuator. By using it in combination with the additional 1/100 attenuator in the sample chamber (on the reference side), the attenuation equivalent to that by a 1/1000 attenuator can be obtained and the measurement of very high absorbance (6 – 7) becomes possible. This time, using a light shielding apparatus as examples, the method for high absorbance analysis is introduced here. | | | | | | |
| | SAMPLE | ACCESSORY | | | | |
| Sample: : Light shielding appar | ratus | Direct light detector (P/N : 1J1-0129) | | | | |
| INSTR | UMENT CONDITIONS | | | | | |
| Instrument : UH4150 | Slit : 8 nm | (P/N : 210-2109) | | | | |
| Scan speed : 300 nm/min | Measurement wavelength range: 400 ~ 7 | 00 nm Attenuator (P/N : 1J0-0551) | | | | |
| [Analysis of Low Absorbance (H | ligh Transmittance) Sample] | | | | | |
| R for the sample of the sample is the sample | | | | | | |
| [Analysis of High Absorbance (| Low Transmittance) Sample: Without Att | enuator] | | | | |
| R | ance (low transmittance) sample, side is low. nd light intensity are not well n with a large noise level. | | | | | |
| High Absorbance Sample | | | | | | |
| [Analysis of High Absorbance (Low Transmittance) Sample: With Attenuator] | | | | | | |
| Attenuator R to the provide the sample and the accurate measurement of high absorbance is possible. S the light intensity balance with the sample side can be adjusted by setting an attenuator on the reference side. As a result, the noise is reduced and the accurate measurement of high absorbance is possible. This time, the 1/100 attenuator, which is built in with the instrument was used in combination with a manually added 1/100 attenuator so as to obtain the effect equivalent to the attenuation by 1/10000 attenuator. | | | | | | |
| | Figure 1 Effect of Attenuator | | | | | |
| KEY WORDS Material/Processing Material Related, Gla | ss/Ceramic, Other Material/Processing | Spectrophotometer (UV) | | | | |
| Material Related, Light Shielding Apparati Polarizer, Absorption Spectrum, Transmit Film, Attenuate, Transmittance, Reflectan | Sheet No. UV130005-01 | | | | | |



[Analysis Method for High Absorbance Using Attenuator]











(Supplemental Explanation 1) Relationship Between Signal Processing (Differential Feedback Method) of UH4150 and Attenuator

UH4150 employs the differential feedback method. With a PMT detector for the UV-Vis region, the applied voltage for the detector is automatically controlled depending on the change in the light intensity. With a PbS detector for the nearinfrared region, the light intensity entering the detector is automatically controlled by the opening and closing of the slit. The advantages are the improved S/N and the shorter sampling integration time (improved throughput). The base of this control is the light beam on the control side (R) or sample side (S), whichever is with the higher light intensity. Thus, when the absorbance of the sample is high (low transmittance), the applied voltage is set lower for the measurement value on the sample side, resulting in the change in the number of digits for the measured value. By using an attenuator, the light intensities on the control side (R) and sample side (S) are balanced and the low light intensity on the sample side (S) is appropriately controlled, resulting in the improved measurement accuracy.

(Supplemental Explanation 2) The Set Positions for the Built-in Attenuator and Additional Attenuator



Figure 5 Schematic Diagram of UH4150 Optical System*

The built-in attenuator is set in the position after the M4 mirror (sector mirror) dividing the beam into double-beams. It will be inserted when an attenuator is set under the analytical conditions.

(Supplemental Explanation 3) Example of Attenuator Selection

| Table 1 | An Example | of Attenuator | Selection |
|---------|------------|---------------|-----------|
| | | | Selection |

| Absorbance | Transmittance | Attenuator |
|------------|---------------------|---|
| Abs3 ~ 4 | 0.1 ~ 0.01(%) | 1/10 |
| Abs4 ~ 5 | 0.01 ~ 0.001(%) | 1/100 |
| Abs5 ~ 6 | 0.001 ~ 0.0001(%) | 1/1000 (combination of 1/10 and 1/100) |
| Abs6 ~ 7 | 0.0001 ~ 0.00001(%) | 1/10000 (combination of 1/100 and1/100) |

Table 1 shows the guideline for the attenuator selection. While it will also be selected depending on the spectral shape of the sample, the selection of the attenuator is made based on the absorbance or the transmittance range of the sample.

| * Due to the limited space, | the descrip | otion partly | / differs | from the | actual | optical | system. |
|-----------------------------|-------------|--------------|-----------|----------|--------|---------|---------|
| | | | | | | | |

KEY WORDS Spectrophotometer (UV) Material/Processing Material Related, Glass/Ceramic, Other Material/Processing Material Related, Light Shielding Apparatus, Attenuator, Attenuation Rate, ND Filter, Polarizer, Absorption Spectrum, Transmittance Spectrum, Reflectance Spectrum, Glass, Sheet No. Film, Attenuate, Transmittance, Reflectance, UV, UH4150, UH4100, U-3900H, U-3900

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